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| SERIAL NUMBER 10/665,122 | FILING DATE 09/22/2003 RULE | CLASS 438 | GROUP ART UNIT 2812 | ATTORNEY DOCKET NO. 2557-000163/US |
|-----------------------------|---------------------------------------|--------------|------------------------|---------------------------------------|

APPLICANTS

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** CONTINUING DATA *****

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** FOREIGN APPLICATIONS *****

REPUBLIC OF KOREA 2002-57456 09/19/2002 *WLC*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/11/2003

| Foreign Priority claimed 35 USC 119 (a-d) conditions met | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | STATE OR COUNTRY KOREA, REPUBLIC OF | SHEETS DRAWING 7 | TOTAL CLAIMS 25 | INDEPENDENT CLAIMS 2 |
|---|---|---|---------------------|--------------------|-------------------------|
| Verified and Acknowledged _____ Examiner's Signature Initials | | | | | |

ADDRESS

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TITLE

Methods of fabricating a semiconductor device having a metal gate pattern

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|---|
| <input type="checkbox"/> All Fees |
| <input type="checkbox"/> 1.16 Fees (Filing) |